L Number	Hits	Search Text	DB	Time stamp
-	61438	yamazaki.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:42
-	2255	ohtani.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:42
-	753	(nickel or ni) and (tft or thin adj film) and yamazaki.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:43
-	191	(nickel or ni) and (tft or thin adj film) and ohtani.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:59
-	839	((nickel or ni) and (tft or thin adj film) and yamazaki.in.) ((nickel or ni) and (tft or thin adj film) and ohtani.in.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:46
-	595	amorphous and ((nickel or ni) and (tft or thin adj film) and yamazaki.in.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:57
-	168	amorphous and ((nickel or ni) and (tft or thin adj film) and ohtani.in.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:57
-	670	(amorphous and ((nickel or ni) and (tft or thin adj film) and yamazaki.in.)) (amorphous and ((nickel or ni) and (tft or thin adj film) and ohtani.in.))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:57
-	544	laser and ((amorphous and ((nickel or ni) and (tft or thin adj film) and yamazaki.in.)) (amorphous and ((nickel or ni) and (tft or thin adj film) and ohtani.in.)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 11:00
-	404	(excimer or eximer) and ((amorphous and ((nickel or ni) and (tft or thin adj film) and yamazaki.in.)) (amorphous and ((nickel or ni) and (tft or thin adj film) and ohtani.in.)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 11:00
-	6692	(nickel or ni) with amorphous	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:59
-	10370	(nickel or ni) same amorphous	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:59
-	572	((nickel or ni) same amorphous) and yamazaki.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:59

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-	170	((nickel or ni) same amorphous) and ohtani.in.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 10:59
-	652	(((nickel or ni) same amorphous) and yamazaki.in.) (((nickel or ni) same amorphous) and ohtani.in.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 11:00
-	497	laser and ((((nickel or ni) same amorphous) and yamazaki.in.) (((nickel or ni) same amorphous) and ohtani.in.))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 11:00
-	365	(excimer or eximer) and ((((nickel or ni) same amorphous) and yamazaki.in.) (((nickel or ni) same amorphous) and ohtani.in.))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 12:55
-	214	(halogen or hcl) and ((excimer or eximer) and ((((nickel or ni) same amorphous) and yamazaki.in.) (((nickel or ni) same amorphous) and ohtani.in.)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/20 12:56

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